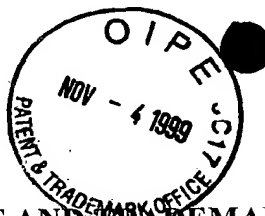


173
Docket No. 8733.20019



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jin JANG, et al.

GAU: TBA

SERIAL NO: 09/350,313

EXAMINER: TBA

FILED: July 9, 1999

FOR: Method of Crystallizing Amorphous Silicon Layer and Crystallizing Apparatus Thereof

**REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136**

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a one-month extension of time be granted to **November 6, 1999** for

- ☐ filing a response to the Official Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☒ responding to the Notice to File Missing Parts of Application dated: August 6, 1999
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐

The required fee of **\$110.00** is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. **50-0911**. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

LONG ALDRIDGE & NORMAN LLP

Kenneth D. Springer
Registration No. 39,843

Date: November 4, 1999

Sixth Floor
701 Pennsylvania Avenue, N.W.
Washington, D.C. 20004
Tel. (202) 624-1200
Fax. (202) 624-1298

CERTIFICATE OF MAILING

37 C.F.R. §1.8

I hereby certify that this paper is being deposited with the U.S. Postal Service as First-Class Mail, postage prepaid, in an envelope addressed to: Assistant Commissioner for Patents, Washington,, D.C. 20231, on the date shown below:

Date

Susan F. Mahon

11/05/1999 TLWU1 00000060 09350313

110.00 DP
65 FC-115